

Article

Not peer-reviewed version

ALD Deposited Hydroxyl-Rich NiOx to Enhance SAM Anchoring for Stable and Efficient Perovskite Solar Cells

Fengming Guo, Xuteng Yu, Yuheng Li, Yong Chen, Chi Li, Chunming Liu, Peng Gao

Posted Date: 24 February 2025

doi: 10.20944/preprints202502.1818.v1

Keywords: hybrid hole selective layer; NiOx; energy level alignment; passivation; inverted perovskite solar cells



Preprints.org is a free multidisciplinary platform providing preprint service that is dedicated to making early versions of research outputs permanently available and citable. Preprints posted at Preprints.org appear in Web of Science, Crossref, Google Scholar, Scilit, Europe PMC.

Copyright: This open access article is published under a Creative Commons CC BY 4.0 license, which permit the free download, distribution, and reuse, provided that the author and preprint are cited in any reuse.

Disclaimer/Publisher's Note: The statements, opinions, and data contained in all publications are solely those of the individual author(s) and contributor(s) and not of MDPI and/or the editor(s). MDPI and/or the editor(s) disclaim responsibility for any injury to people or property resulting from any ideas, methods, instructions, or products referred to in the content.

Article

ALD Deposited Hydroxyl-Rich NiO_x to Enhance SAM Anchoring for Stable and Efficient Perovskite Solar Cells

Fengming Guo 1,2,3, Xuteng Yu 2,3,4,5, Yuheng Li 1,2,3, Yong Chen 2,3,5, Chi Li 2,3,5, Chuming Liu 2,3,4,5 and Peng Gao 2,3,5,*

- ¹ College of Chemistry and Materials Science, Fujian Normal University, Fuzhou, Fujian 350108, China
- ² State Key Laboratory of Structural Chemistry, Fujian Institute of Research on the Structure of Matter, Chinese Academy of Sciences, Fuzhou, Fujian 350002, P. R. China
- ³ Laboratory of Optoelectronic Materials and Advanced Manufacturing, College of Materials Science and Engineering, Huaqiao University, Xiamen, 361021, P.R.China.
- ⁴ Fujian College, University of Chinese Academy of Sciences, Fuzhou, 350002, China
- ⁵ University of Chinese Academy of Sciences, Beijing 100049, China
- * Correspondence: peng.gao@fjirsm.ac.cn (P.G.); ymyu@hqu.edu.cn

Abstract: The interface between nickel oxide (NiO_x) and self-assembled monolayers (SAMs) in perovskite solar cells (PSCs) often suffers from limited adsorption strength, poor energy-level alignment, and inadequate defect passivation, which hinder device performance and stability. To address these issues, we introduce a hybrid hole selective layer (HSL) combining atomic layer deposition (ALD)-fabricated NiO_x with full-aromatic SAM molecules, creating a highly stable and efficient interface. ALD NiO_x, enriched with hydroxyl groups, provides robust adsorption sites for the SAM molecule MeO-PhPACz, ensuring a strong, stable interaction. This hybrid HSL enhances energy-level alignment, hole selectivity, and defect passivation at the NiO_x/perovskite interface. Devices utilizing this approach demonstrate significant performance improvements, achieving a power conversion efficiency (PCE) of 21.74%, with reduced voltage losses and minimal hysteresis. Furthermore, operational stability tests reveal enhanced durability under elevated humidity and temperature conditions. These findings highlight the potential of ALD NiO_x and SAM hybrid HSL to overcome existing barriers, advancing the commercial viability of PSC technologies.

Keywords: hybrid hole selective layer; NiO_x; energy level alignment; passivation; inverted perovskite solar cells

1. Introduction

Organic-inorganic hybrid perovskite solar cells (PSCs) have made remarkable strides in power conversion efficiency (PCE) in a short time [1–5]. Among these, the inverted p-i-n structure has attracted considerable attention for its low-temperature fabrication process, reduced hysteresis, enhanced stability, and ability to meet the structural demands of tandem solar cells [6,7]. In the fabrication of inverted PSCs, a hole selective layer (HSL) is first deposited onto the indium tin oxide (ITO) substrate. This layer not only ensures efficient hole collection but also minimizes charge recombination at the interface, which plays a critical role in the crystallization and nucleation of the perovskite material. Therefore, the development of high-performance HSL is essential for achieving high-efficiency inverted PSCs.

At present, a wide variety of HSLs have been employed in inverted PSCs. Among these, nickel oxide (NiO_x) has garnered significant attention owing to its cost-effectiveness, facile manufacturability, outstanding hole extraction efficiency, and well-aligned energy levels [8–12]. The performance and stability of NiO_x-based PSCs are frequently hindered by undesirable reactions

between the perovskite layer and highly reactive Ni³⁺ species, as well as charge carrier recombination at the NiO_x/perovskite interface [13–15]. To mitigate these issues, the combination of NiO_x with self-assembled monolayers (SAMs) has emerged as a highly effective strategy [8,11,12,16,17]. Jen et al. employed bromobenzoic acid (Br-BA) to modify the surface of NiO_x nanoparticles, reducing interfacial defects and trap states, enhancing perovskite crystallization quality, and optimizing energy level alignment [18]. You et al. treated NiO_x nanoparticles with H₂O₂, which enhanced the film's conductivity and surface hydroxyl content, promoting SAM anchoring [19]. Bi et al. incorporated sodium hexametaphosphate (SHMP) to modify NiO_x, improving the surface hydroxyl density and film uniformity, thereby enhancing the anchoring of Me-4PACz and reducing the opencircuit voltage loss in wide-bandgap perovskite solar cells [12].

In previous work, we proposed a Ni vacancy defect modulate approach to leverage the conformal growth and surface self-limiting reaction characteristics of the atomic layer deposition (ALD) -fabricated NiO_x by varying the O₂ plasma injection time to induce self-doping [20]. We fabricated ultra-thin NiO_x films with excellent conductivity, an optimal Ni³⁺/Ni²⁺ ratio, and stable surface states, serving as the HSL in p-i-n PSCs. However, interface defects at the NiO_x/PVK interface can induce perovskite degradation, and a higher density of defects is typically present at the bottom perovskite interface. Building upon prior studies, the incorporation of SAMs with NiO_x has been demonstrated to enhance surface hydroxyl density, strengthen SAM anchoring, mitigate surface defects, and ultimately improve film quality [12,18,19]. Consequently, we propose the introduction of a novel SAM at the NiO_x/PVK interface to address the aforementioned detrimental characteristics.

Herein, we deposited a layer of MeO-PhPACz (hereafter referred to as MeO-Ph) [21] onto the ALD-deposited NiOx, which has a surface rich in -OH groups, thereby providing more adsorption sites for the SAM molecules. Compared to ITO/MeO-Ph, the binding energy between ALD-NiOx and MeO-Ph is increased, with stronger and more stable interactions and also improved hole extraction capability. In contrast to ALD-NiOx, MeO-Ph effectively passivates surface defects of NiOx, significantly suppressing redox reactions at the HSL/PVK interface and notably enhancing the work function of the HSL. As a result, the hybrid HSL with well-aligned energy levels, stable surface states, and efficient hole extraction was achieved. The corresponding device showed a marked increase in PCE from 19.86% (ALD-NiOx) and 20.53% (MeO-Ph) to 21.74% (ALD-NiOx/MeO-Ph), with minimal hysteresis. Stability tests conducted on unencapsulated devices under various aging conditions demonstrated that devices based on ALD-NiOx/MeO-Ph exhibited excellent long-term stability.

2. Results and Discussion

Excellent optical transmittance significantly influences the short-circuit current of the device. We measured the transmittance of three thin films in the 350 nm-800 nm wavelength range. The results show that all three films exhibit transmittance above 90%, with MeO-Ph achieving an optical transmittance exceeding 95% due to its ultrathin nature. To investigate the interaction between MeO-Ph and NiOx (unless otherwise specified, NiOx refers to ALD-NiOx), we used XPS to evaluate the surface chemical properties of ITO/NiOx before and after MeO-Ph adsorption. Pure MeO-Ph adsorbed on an ITO substrate was used as a reference sample, with the elemental composition summarized in Table S1. The differences in phosphorus (P) in Figure 1a and nitrogen (N) in Table S1 confirm the successful adsorption of MeO-Ph on the ITO/NiOx surface. The concentration of P atoms in the ITO/NiOx/MeO-Ph sample is 4.45%, significantly higher than the 3.29% observed in the ITO/MeO-Ph sample, indicating that the presence of NiOx enhances the adsorption of MeO-Ph.

Furthermore, the concentration of nickel (Ni) in the NiO_x substrate decreases after MeO-Ph adsorption, suggesting that the signal from the NiO_x substrate is partially obscured by the adsorbed MeO-Ph layer. To more clearly observe the differences between the samples, we performed peak fitting on the high-resolution XPS spectra of Ni 2p and O 1s. In the Ni 2p spectrum, the binding energy of Ni³⁺ increased from 855.78 eV to 855.97 eV after the adsorption of MeO-Ph, with a similar shift observed for Ni²⁺, which increased from 854.14 eV to 854.33 eV. Comparable changes were also observed in the O 1s XPS signals of NiO_x/MeO-Ph compared to pristine NiO_x. These chemical shifts

suggest that oxygen atoms in MeO-Ph donate lone pair electrons to the vacant orbitals of nickel atoms, leading to the formation of coordination covalent bonds (P=O-Ni) at the interface. This provides compelling evidence of charge transfer between MeO-Ph and NiOx [22–24]. Additionally, in the O 1s spectrum, a signal corresponding to C-O at 532.25 eV was detected in the NiOx/MeO-Ph sample, which originates from the methoxy group of MeO-Ph. This further confirms the successful adsorption of MeO-Ph onto the NiOx surface [21]. Based on previous studies [22], we propose a bonding model between NiOx and MeO-Ph (Figures 1d and 1e). Compared to ITO, NiOx prepared via ALD exhibits metal vacancies (VNi) on its surface, which increase the number of highly reactive oxygen dangling bonds. This provides additional adsorption sites for MeO-Ph. This enables the formation of a robust tridentate adsorption configuration.

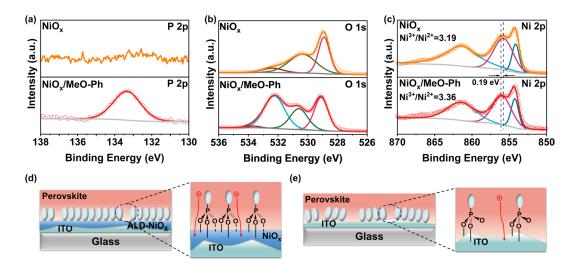


Figure 1. XPS spectra of (a) P 2p, (b) O 1s, and (c) Ni 2p for the three films, and adsorption patterns of MeO-Ph on (d) NiO_x and (e) ITO surface.

From the AFM images (Figure S2a-c), a noticeable increase in RMS roughness is observed for NiO_x/MeO-Ph and MeO-Ph surfaces compared to bare NiO_x. This indicates the successful attachment of MeO-Ph onto the substrate surface. Due to the limitations of the spin-coating process, the RMS of MeO-Ph is larger than that achieved with the ALD process. Following MeO-Ph adsorption, KPFM measurements reveal a decrease in CPD from -0.41 V to -0.50 V and -0.45 V, respectively. This significant shift in CPD serves as a reliable indicator of successful MeO-Ph adsorption. Moreover, the CPD of NiO_x/MeO-2PACz is lower than that of NiO_x, indicating that the adsorption of MeO-Ph leads to an increase in the W_F of NiO_x. This increase is attributed to the intrinsic dipole moment of MeO-Ph, oriented from the carbazole group to the phosphonic acid group, which generates an electric field at the surface. Additionally, since the E_F of MeO-Ph is lower than that of NiO_x, electron transfer occurs from NiO_x to MeO-Ph upon contact, forming a space charge region. The combined effects of the dipole layer and the space charge region contribute to the enhanced W_F of NiO_x [25].

The W_F values obtained from UPS measurements confirm that the introduction of MeO-Ph results in a more favorable alignment of the hole extraction energy levels. The W_F values for NiO_x, MeO-Ph, and NiO_x/MeO-Ph are -4.52 eV, -4.87 eV, and -4.98 eV, respectively (Figure 2a-b). These changes are likely to contribute to improvements in Voc and Jsc. Based on UV-vis spectroscopy results, the optical band gaps (E_g) for NiO_x, MeO-Ph, and NiO_x/MeO-Ph, calculated via Tauc plots, are 3.87 eV, 3.19 eV, and 3.82 eV, respectively. The E_g value for MeO-Ph is consistent with previous literature [21]. The reduction in E_g for NiO_x/MeO-Ph is attributed to changes in the Ni²⁺/Ni³⁺ ratio [23] (Figure S3a).

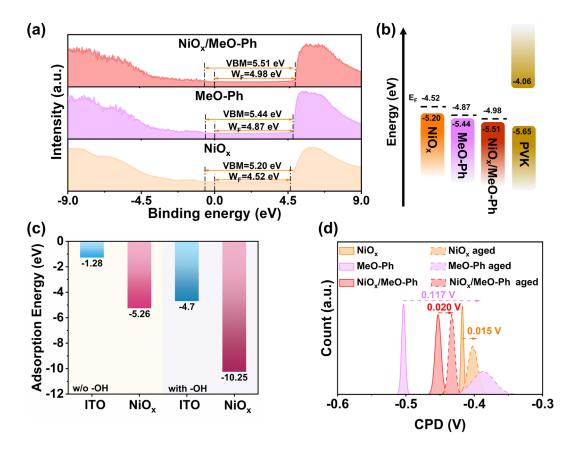


Figure 2. (a) UPS plots, and (b) energy band schematics of NiO_x, MeO-Ph, and NiO_x/MeO-Ph; MeO-Ph on hydroxyl-free ITO, NiO_x and hydroxyl-containing ITO, NiO_x surfaces, (c) specific adsorption energy results from theoretical calculation, (d) CPD changes before and after aging of different substrates.

We designed the corresponding structural models for DFT calculations to accurately illustrate the ability of polyhydroxy NiOx to enhance the adsorption of self-assembled molecules (Figure. S4). As shown in Figure 2c, when no -OH groups are present on the substrate surface, the binding energies of MeO-Ph on ITO and NiOx are -1.28 eV and -5.26 eV, respectively. However, when -OH groups are present at the substrate interface, the binding energy of MeO-Ph significantly increases to -4.7 eV and -10.25 eV. These results clearly demonstrate that the presence of NiOx significantly enhances the adsorption energy of MeO-Ph on the substrate, and the existence of -OH groups further promotes this increased adsorption strength. To more directly observe the stability of MeO-Ph on different substrates, we fabricated HSL structures of ITO/NiOx, ITO/MeO-Ph, and ITO/NiOx/MeO-Ph and subjected them to aging tests in air (60°C, 50 ± 10% relative humidity). The changes in surface potential of the films before and after aging were recorded using KPFM. As shown in the figure, prior to aging, all three films exhibit relatively uniform surface potential, indicating that MeO-Ph is evenly deposited on both ITO and NiOx surfaces. After 480 hours of aging, the CPD of ITO/MeO-Ph significantly decreases (ΔCPD ≈ 0.117 V), whereas the CPD changes of ITO/NiO_x and ITO/NiO_x/MeO-Ph are only 0.015 V and 0.020 V, respectively. This suggests that the substrate with NiOx as a seed layer can securely anchor MeO-Ph to the surface, thereby enhancing the operational stability of the corresponding devices. We hypothesize that the CPD change in ITO/MeO-Ph is due to the hydrolysis of the coordinating metal of the hydroxyl groups linked to the SAM molecules in the atmosphere, leading to the desorption of the SAM molecules [26,27]. Additionally, it is likely that the tridentate binding strength between SAM and NiOx is stronger than the bidentate binding between SAM and ITO. Furthermore, the higher hydroxyl density on the NiOx surface compared to ITO further contributes to the improved stability.

To evaluate changes in defect density, we fabricated p-type devices with a planar structure of ITO/HSL (NiOx, MeO-Ph, NiOx/MeO-Ph)/PVK/spiro-OMeTAD/Ag, and the J-V characteristics

measured under dark conditions are shown in Figure 3a. The corresponding data is plotted in a logarithmic-logarithmic coordinate system. As the applied voltage increases, the current exhibits a linear increase in the ohmic contact region, followed by a rapid rise above the trap-filling limit voltage (VTFL). The VTFL values for NiOx/MeO-Ph and MeO-Ph are 0.36 V and 0.42 V, respectively, both lower than the 0.45 V for NiOx. Using the formula (Equation S1), the defect density is calculated to decrease from 8.13×10-15 cm⁻³ (NiO_x) to 6.91×10-15 cm⁻³ (MeO-Ph) and 5.84×10-15 cm⁻³ (NiO_x/MeO-Ph), indicating that the introduction of MeO-Ph effectively passivates the HSL/PVK interface defects [28]. To evaluate the impact of different HSL on charge extraction and transport, we performed PL spectroscopy measurements, as shown in Figure S5. Compared to the MeO-Ph/PVK sample, the NiO_x/MeO-Ph/PVK sample exhibits lower PL intensity, indicating that NiO_x/MeO-Ph provides better hole extraction and transport capabilities than MeO-Ph [19]. The lowest PL intensity of NiOx is likely due to carrier recombination at the NiOx/PVK interface defects. The TRPL was further used to quantify the carrier dynamics, where the data was fitted to a double-exponential decay function, with the results shown in Table S2. The decay time constant τ_1 is attributed to the charge extraction by the HSL, while τ_2 corresponds to the radiative recombination of free carriers within the perovskite layer [23]. The device based on NiO_x/MeO-Ph exhibits the shortest τ_1 and the longest τ_2 , confirming that the mixed HSL not only enhances the hole extraction rate but also passivates the NiO_{*}/PVK interface defects.

TPV and TPC are direct methods to investigate carrier behavior (recombination or extraction) [29]. The characterization results, shown in Figure 3b and Figure S6, clearly indicate that for devices based on NiOx/MeO-Ph, the photocurrent decay time is significantly reduced, while the photovoltage decay time is markedly increased. This suggests a reduction in intrinsic defects, faster charge extraction, and suppressed interfacial recombination. Additionally, to assess the charge recombination state in the devices, the dependence of Voc and Isc on light intensity was measured for the PSCs. As shown in Figure 3c, the device based on NiOx/MeO-Ph exhibits the smallest slope of 1.16 KB/q. The decrease in this slope can be attributed to the effective passivation of the NiOx/PVK interface by MeO-Ph [30]. However, we observed that the slope for devices based on MeO-Ph is slightly larger than that of NiOx-based devices. This may be due to the partial dissolution of the SAM during the perovskite deposition process, caused by the DMF/DMSO solvents, which leads to a reduction in interface coverage and subsequent interfacial charge recombination as a result of direct contact between the perovskite and ITO [31]. Figure 3d shows the relationship between Isc and light intensity. The closer the α value is to 1, the less trap-assisted recombination occurs [32]. The results indicate that the device based on NiO_x/MeO-Ph exhibits an α value closest to 1, which is consistent with the Voc-light intensity dependence observed earlier. In EIS, the value of Rrec is proportional to the diameter of the semicircle, with a larger diameter indicating less charge recombination [23]. The EIS fitting results show that the R_{rec} values for NiO_x, MeO-Ph, and NiO_x/MeO-Ph are 598.1 Ω , 554.7 Ω , and 599.8 Ω , respectively. The smaller R_{rec} value for MeO-Ph may be due to the partial dissolution of the SAM by DMF/DMSO, leading to an increase in defects at the HSL/PVK interface. The Mott-Schottky curve (Figure 3f) is typically used to measure the built-in potential (V_{bi}) of PSCs [33]. The V_{bi} of the NiO_x/MeO-Ph-based device is 0.95 V, higher than that of NiO_x (0.92 V) and MeO-Ph (0.94 V). The higher V_{bi} is attributed to the optimization of energy level alignment, which provides a stronger driving force for carrier extraction and separation, aiming for a higher Voc.

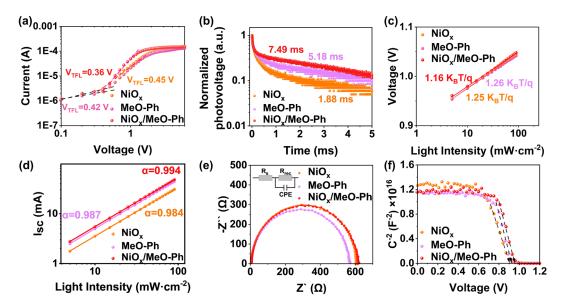


Figure 3. NiO_x, MeO-Ph, and NiO_x/MeO-Ph based on (a) Dark J-V characteristic plots for hole-only devices, (b) TPV plots of NiO_x, MeO-Ph, (c-d) *Voc* and *Isc* plots of the corresponding PSCs as a function of light intensity, (e) EIS plots of the corresponding devices, the insets show the equivalent circuits used to fit the Nyquist plots, (f) Mott-Schottky plots of different PSCs.

The crystallization and film formation of the perovskite layer are largely influenced by the HSL. According to the SEM images (Figure 4b and S7-8), the perovskite grains based on MeO-Ph and NiO_x/MeO-Ph are significantly larger, with an increase in film thickness as well. To explain these observations, we conducted water contact angle measurements (Figure S9). The results show that NiO_x exhibits good surface wettability, which facilitates the formation of smaller perovskite grains. In contrast, the water contact angles for MeO-Ph and MeO-Ph/NiO_x are significantly higher. Therefore, the changes in perovskite grain size can be attributed to an increase in the surface tension of the substrate, which enhances its hydrophobicity and reduces the mobility of grain boundaries, thereby favoring the growth of columnar grains [34]. The variation in thickness may be due to the introduction of MeO-Ph, which reduces surface defects of NiO_x and provides a more favorable environment for perovskite film growth [35]. XRD patterns (Figure S10) and Tauc plots (Figure S11) show that there are no significant changes in crystallization quality, crystal orientation, or optical bandgap of perovskite films grown on different HSL.

To evaluate the performance of NiOx/MeO-Ph mixed HSL in single-junction solar cells, we fabricated p-i-n structured PSCs with the architecture of ITO/HSL/PVK/C60/BCP/Ag, as shown in Figure 4a. Devices based on NiOx and MeO-Ph as the HSL were prepared for comparison. The J-V characteristics of the optimized devices with different HSLs are shown in Figure 4b. Table S3 summarizes the photovoltaic parameters. The best-performing device with the NiOx/MeO-Ph mixed HSL achieved a PCE of 21.74%, with *Voc*, *Jsc*, and *FF* values of 1.07 V, 23.74 mA cm⁻², and 84.43%, respectively. Compared to the pure NiOx device, the incorporation of MeO-Ph effectively passivated interface defects, leading to significant improvements in *Jsc*, and *FF*.

In contrast to the pure MeO-Ph device, the NiOx/MeO-Ph device exhibited enhanced *Voc, FF*, and *Jsc* due to stronger SAM adsorption, reduced shunt paths, and improved hole extraction efficiency. Figure 4d and Figure S12 present the statistical distribution of various parameters for devices fabricated with different HSLs. Devices based on the NiOx/MeO-Ph mixed HSL exhibit improvements in all parameters. Among them, MeO-Ph shows the lowest *Voc*, which is attributed to the perovskite deposition process, where some SAM molecules are washed away, leading to significant interface carrier recombination [31], consistent with the results from EIS and *Voc* -light intensity dependence tests. The *Jsc* value of the devices is in good agreement with the *Jsc* calculated from the external quantum efficiency (EQE) measurements, with the improvement in *Jsc* attributed

to the enhanced hole transport capability of the HSL. Additionally, the devices with different HSL demonstrate stable photocurrent and PCE output at the maximum power point (Figure 4f).

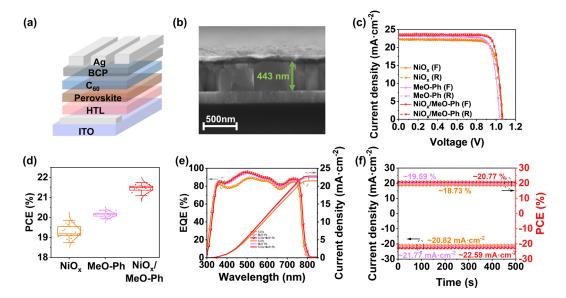


Figure 4. (a) Device schematic of p-i-n structured PSCs, (b) Cross-sectional thickness plots of perovskite deposited on NiO_x/MeO-Ph surfaces, (c) Forward and Reverse scanning *J-V* curves under simulated AM 1.5G solar illumination (100 mW cm⁻²), (d) Extraction of PCE distributions from *J-V* measurements of NiO_x, MeO-Ph, and NiO_x/MeO-Ph based PSCs (20 individual devices), (e) EQE spectra of the best performing device with an active area of 0.1 cm² for the integrated *Jsc*, and (f) power output stabilized at the point of maximum power over 500 s (SPO).

The detrimental redox reactions at the NiO_x/PVK interface represent a major challenge for the commercialization of PSCs. We aim to mitigate this issue by introducing MeO-Ph. Perovskite films were deposited on different HSLs, and their changes were monitored in an atmosphere at 60°C and 60±10% relative humidity. As shown in Figure S13, after 240 hours of heating, the (100) crystallographic peak of the perovskite film deposited on the three different HSLs still predominated. To gain further insight into whether the adverse interfacial reactions were suppressed, we calculated the intensity ratio of PbI₂(001) to PVK(100) over time. The results indicated that for perovskites grown on MeO-Ph and NiO_x/MeO-Ph, the PbI₂(001)/PVK(100) ratio was significantly lower compared to those grown on NiO_x. This phenomenon suggests that the introduction of MeO-Ph effectively alleviates the detrimental redox reactions at the NiO_x/PVK interface.

To further demonstrate the advantages of the NiOx/MeO-Ph hybrid HSL, we investigated the operational stability of the corresponding devices under different environmental conditions. The results reveal that the hybrid HSL-based devices exhibit the highest stability, whether in an ambient atmosphere at 60°C with a relative humidity of 60±10% (Figure 5b) or in a nitrogen environment at 85°C (Figure 5c). The efficiency degradation observed for the pure MeO-Ph device may be attributed to desorption or detachment of the SAM under high-humidity conditions [26], as no significant efficiency loss was observed in the nitrogen environment at 85°C. To verify the applicability of the hybrid HSL, we fabricated devices using various perovskite compositions, including MAPbI₃ (1.59 eV), Cs_{0.05}(FA_{0.92}MA_{0.08})_{0.95}Pb(I_{0.92}Br_{0.08})₃ (1.59 eV), and Cs_{0.05}FA_{0.8}MA_{0.15}Pb(I_{0.75}Br_{0.25})₃ (1.68 eV) and analyzed the variations in *Jsc* and PCE. As shown in Figure 5d and S14, the hybrid HSL consistently delivers significant enhancements in both *Jsc* and PCE compared to NiO_x and MeO-Ph, regardless of the same bandgap with different compositions or different bandgaps. This confirms that the hybrid HSL possesses broad applicability across various perovskite systems. Moreover, the MPP tracking under harsh conditions (unencapsulated, continuous illumination (1 sun), and negative electric bias) (Figure 5e) showed that MPP of NiO_x -based PSCs dropped quickly (~ 79 % after 500 h), while the

PSCs with NiOx/MeO-Ph as HSL remain over 95 % of its initial PCE value after 500 h, indicating better operational stability.

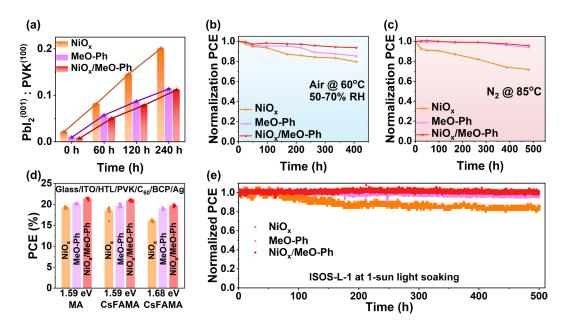


Figure 5. (a) plots of normalized PbI₂(001): PVK(100) intensities versus aging time for stability measure-ments were performed at 60° C and $60 \pm 10^{\circ}$ relative humidity, Long-term stability tests of unencapsulated PSCs in (b) air at $60 \pm 10^{\circ}$ relative humidity and 60° C, (c) N₂ environment at 85° C, (d) PCE performances of NiO_x, MeO-Ph, and NiO_x/MeO-Ph in different perovskite. (e) Stabilized power output at MPP at RT and N₂ under 1 Sun illumination.

3. Materials and Methods

3.1. Materials and Synthesis

All reagents and solvents used were commercially available without further purification. Methylammonium iodide (MAI) was synthesized by the reaction of hydriodic acid (57wt% in H₂O, Aldrich), methylamine (30-33wt% in ethanol, Aladdin). Formamidinium iodide (FAI), methylammonium bromide (MABr), and methylammonium chloride (MACl) were synthesized according to the procedures in previous publications [21]. Lead iodide (PbI₂), lead bromide (PbBr₂), Cesium iodide (99.9%), N, N-dimethylformamide (DMF, 99.8%, anhydrous), dimethyl sulfoxide (DMSO, 99.9%, anhydrous), N-Methylpyrrolidone (NMP), chlorobenzene (CB, 99.8%, anhydrous), ethyl acetate (EA, 99.8%, anhydrous), 2-propanol (IPA, 99.8%, anhydrous), nickel oxide (Ni₂O₃) were purchased from Sigma-Aldrich. Lead iodide (99.998%) were purchased from TCI. Fullerene-C60 and 2,9-dimethyl-4,7-diphenyl-1,10-phenanthroline (BCP) were purchased from Lumtec. Bismethylcyclopentadienyl-nickel (Ni(MeCp)₂, 99.9999%) were purchased from Nanjing Ai Mou Yuan Scientific Equipment. The synthesis procedure of MeO-PhPACz was reported in the previous work [21].

3.2. Computational Method

All the calculations based on the density functional theory (DFT) and the Projector Augmented Wave (PAW) potential were implemented with the Device Studio (https://iresearch.net.cn/cloudSoftware), which provides a number of functions for performing visualization, modeling and simulation. Molecular geometry simulation using BDF [36–39] software integrated in Device Studio program. We used the B3LYP functional to calculate the molecules, and optimized the molecular structure using the Def2-SVP basis set. For calculation of doping mechanism, DFT calculations were performed by using the DS-PAW [40] package in Device Studio program. The generalized gradient approximation in the Perdew-Burke-Ernzerhof (PBE) format was

used to compute exchange and correlation energies and a plane wave basis set cutoff energy of 650 eV were adopted. Grimme's DFT-D3 was used for dispersion correction. A mesh of $1\times1\times1$ Gammacentered k-points was used for the Brillouin-zone integration. The criterion of electron self-consist iteration was set as 1.0×10^{-5} eV and the maximum force was relaxed down to 0.05 eV Å⁻¹.

3.3. Device Fabrication

3.3.1. Preparation of Hole Selective Layer

Preparation of ALD NiO_x: Indium tin oxide (ITO) glass (7-9 Ω m⁻² square, AGC, Japan) was ultrasonically cleaned in deionized water and ethanol for 15 min each time and dried with N₂ flow. High-temperature tape is applied to one side of the ITO to prevent back contact from being formed by NiO_x deposited in this area. Next, the substrates were further cleaned with O₂ plasma clean for 10 min. The ITO was transferred to the ALD reaction chamber (PEALD-200R, Kemin Electronic Equipment Technology Co.) with the substrate temperature set at 150°C, chamber pressure below 10⁻³ torr, and reaction gas flow rate of 50 sccm. ALD NiO_x is deposited using Ni(MeCp)₂ as precursor and O₂ plasma as co-reactant. The Ni(MeCp)₂ bubbler is kept at 60°C to ensure adequate vapor pressure and is dosed using Ar carrier gas through a delivery line heated to 100°C. Each ALD cycle consists of 0.9 s Ni(MeCp)₂ dose, 10 s purge time, 7.5 s O₂ plasma exposure (200 W) and 10 s purge time. After deposition, the NiO_x was quickly transferred to an N₂ glove box and the high-temperature tape was peeled off before proceeding to the next application.

MeO-Ph hole selective layer: The cleaned ITO substrates were treated with O_2 plasma for further cleaning. A 2 mg/mL solution of MeO-PhPACz in ethanol was spin-coated onto the substrate at 3000 rpm for 30s, followed by annealing on a hot plate at 100° C.

NiO_x/MeO-Ph hybrid hole selective layer: A 2 mg/mL solution of MeO-PhPACz in ethanol was spin-coated onto the ALD-deposited NiO_x at 3000 rpm for 30s, followed by annealing on a hot plate at 100° C.

3.3.2. Fabrication Process of Perovskite Films

MAPbI $_3$ perovskite films: The 1.3M perovskite precursor solution was prepared by dissolving a mixture of MAI and PbI $_2$ in a mixed solvent DMF/DMSO/NMP (835:75:90, v/v), and then magnetically stirring for several hours. 60 μ L solutions were spin-coated at 1000 rpm for 10 s and 5000 rpm for 20 s. 140 μ L of CB was dropped on the substrates in the last 5 s to form intermediate films. The resulting perovskite film was annealed at 100°C for 10 min.

Cs0.05(FA0.92MA0.08)0.95Pb(I0.92Br0.08)3 perovskite films: The 1.47M perovskite precursor solution was prepared by dissolving a mixture of PbI2, CsI, PbBr2, MABr and FAI in a mixed solvent DMF/DMSO (4:1, v/v), and then magnetically stirring for several hours. 60 μ L solutions were spin-coated at 1000 rpm for 10 s and 5000 rpm for 25 s. 110 μ L of EA was dropped on the substrates in the last 10 s to form intermediate films. The resulting perovskite film was annealed at 100°C for 20 min.

Cs0.05FA0.8MA0.15Pb(I0.75Br0.25)3 perovskite films :1.4 M wide-bandgap (1.68 eV) perovskite precursor solution was prepared by dissolving a mixture of FAI, MABr, PbI2, PbBr2 and CsI in a mixed solvent DMF/DMSO (4:1, v/v), and then magnetically stirring for several hours. 100 μ L perovskite precursor solution was spread on the whole area of HSLs/ITO substrates and spun using the spin-coating process (3500 rpm for 40 s, 5 s acceleration). According to the antisolvent method, 150 μ l of ethyl acetate was dropped on the film in 10 s before the end of the program. The resulting perovskite film was then annealed at 100°C for 30 min.

Finally, 25 nm of C60 was sequentially evaporated at rates of 0.2 Å/s sequentially evaporated. Next, 140 μ L of BCP solution (0.5 mg/mL in IPA) was dynamically spin-coated at 6000 rpm for 30 s. Finally, a 120 nm Ag electrode was thermally evaporated under a vacuum of 5 × 10⁻⁴ Pa.

3.4. Characterizations and Measurements

The grazing incidence X-ray diffraction (GI-XRD) measured by the x-ray diffraction (XRD, Rigaku TTRAXIII, Ibaraki, Japan) at an incident angle of 0.5°. X-ray diffraction (XRD) was measured with a PANalytical X'Pert3 powder diffractometer equipped with a Cu-sealed tube (λ =1.541874 Å) at 40 kV and 40 mA. Ultraviolet-visible (UV-Vis) absorption spectra and Transmission spectra were recorded on a Cary 5000 spectrophotometer. The water contact angle was measured by a DataPhysics contact angle tester. The top-view and cross-section morphologies of the perovskite films were investigated using field emission scanning electron microscopy (SEM) (Apreo S LoVac, Thermo). The surface roughness and surface potential of perovskite films by atom force microscopy (AFM) and kelvin probe force microscopy (KPFM) were carried out using Oxford Jupiter XR. The X-ray photoelectron spectrum (XPS) and ultraviolet photoelectron spectroscopy (UPS) were performed using an X-ray photoelectron spectroscopy system (Axis Supra, Shimadzu) with Al K α X-ray radiation (1486.6 eV) as the X-ray source. Photoluminescence (PL) and time-resolved photoluminescence (TRPL) were carried out with a series of Fluorescence spectrometers (FLS-980). The excitation and emission wavelengths are 460 nm and 770 nm for the TRPL measurement, respectively. The transient photovoltage (TPV), transient photocurrent (TPC), Electrochemical impedance spectroscopy (EIS), and Mott-Schottky measurements were carried out using an electrochemical workstation (Zennium Zahner, Germany). Space-charge limited current (SCLC) measurement was performed on a Keithley 2401 source meter ranging from 0 V to 5 V. The photovoltaic performance was measured on a source meter (Keithley 2401) under AM 1.5G (0.1 W/cm²) illumination with a solar simulator (Enli Tech), current density-voltage (*J-V*) characteristics were recorded by a source meter (Keithley 2401) with 100 mV/s scan speed. The external quantum efficiency (EQE) spectrum was measured by the EQE system (QE-R 3011, Enli) at DC mode.

3.5. Stability Measurement

The long-term stability assessment of the perovskite solar cells was carried out by repeating the J-V characterizations over various times. For the thermal stability test, the devices were stored at 85°C in N_2 for 500 h. Then 60°C and 60% RH in the air for 400 h. For the storage stability test, unencapsulated devices were kept in a dark condition with N2 at room temperature for 960 h. Thereafter, place in air at 25°C with a relative humidity of 60% for 120 h. The long-term MPP tracking was carried out on Multi-Channels Solar Cells Stability Test System, Wuhan 91PVKSolar Technology Co. Ltd., China. The solar cells were fixed at the V_{mpp} and under constant 1 sun illumination and the current density variation was recorded every 10 s at room temperature in a nitrogen-flowing atmosphere was recorded.

4. Conclusions

In summary, the NiOx/MeO-Ph hybrid HSL strategy offers multiple advantages. On the one hand, compared to pure MeO-Ph, the incorporation of NiOx provides more adsorption sites, enhances adsorption strength, facilitates energy band alignment at the HSL/PVK interface, prevents direct contact between the perovskite and ITO, and improves the hole selectivity of the HSL. On the other hand, compared to pure NiOx, the introduction of MeO-Ph achieves dual passivation of defects at the perovskite bottom surface and the HSL/PVK interface, effectively suppressing undesirable interfacial redox reactions. Devices based on the hybrid HSL exhibit superior performance and demonstrate the longest operational lifetimes under various environmental conditions. These findings confirm that the application of the hybrid HSL in single-junction PSCs is a highly advantageous approach. We believe this study provides a solid foundation for the development of high-performance and highly stable p-i-n PSCs and accelerates their path toward commercialization.

Supplementary Materials: The following supporting information can be downloaded at the website of this paper posted on Preprints.org. Figure S1: Light transmittance of NiO_x, MeO-Ph, and NiO_x /MeO-Ph; Figure S2: Surface roughness of (a) NiO_x, (b) MeO-Ph and (c) NiO_x/MeO-Ph, CPD distribution of (d-e) three films (from left to right: NiO_x, MeO-Ph, NiO_x/MeO-Ph); Figure S3: (a-b) (α hv)x vs. hv plots (x = 2 or 1/2) of NiO_x, MeO-Ph, and

NiOx/MeO-Ph; Figure S4: Theoretical adsorption mode of MeO-Ph on surfaces without -OH (a) ITO, (b) NiOx, and with -OH (c) ITO, (d) NiOx; Figure S5: NiOx, MeO-Ph, and NiOx/MeO-Ph based on (a) PL spectra, and (b) TRPL spectra; Figure S6: TPC plots of NiOx, MeO-Ph, and NiOx/MeO-Ph based PSCs; Figure S7: Top-view particle size distribution plots of perovskite deposited on (a) NiOx, (b) MeO-Ph and (c) NiOx/MeO-Ph surfaces; Figure S8: Cross-sectional thickness plots of perovskite deposited on (a) NiOx and (b) MeO-Ph surfaces; Figure S9: Water contact angle plots of perovskite deposited on (a) NiOx, (b) MeO-Ph and (c) NiOx/MeO-Ph surfaces; Figure S10: XRD spectra plots of perovskite deposited on NiOx, MeO-Ph and NiOx/MeO-Ph surfaces; Figure S11: (αhv)² vs. Energy (eV) plots of perovskite deposited on NiO_x, MeO-Ph and NiO_x/MeO-Ph surfaces; Figure S12: Extraction of (a) Voc, (b) Jsc and (c) FF distributions from J-V measurements of NiOx, MeO-Ph, and NiOx/MeO-Ph based PSCs (20 individual devices); Figure S13: Stability measurements were performed at 60°C and 60 ± 10% relative humidity. Includes evolution of XRD patterns of perovskite deposited on (a) NiOx, (b) MeO-Ph and (c) NiOx/MeO-Ph; Figure S14: Jsc performances of NiOx, MeO-Ph, and NiOx/MeO-Ph in different perovskite; Figure S15: (a) Isc and (b) PCE performances of NiOx/(MeO-2PACz or MeO-Ph) mixed hole transport layer; Table S1: Atomic concentrations of various major elements of NiOx, MeO-Ph, and NiOx/MeO-Ph; Table S2: TRPL fitting parameters based on NiOx, MeO-Ph, and NiOx/MeO-Ph devices; Table S3: NiOx, MeO-Ph, and NiOx/MeO-Ph as photovoltaic parameters for HSL best PSCs.

Author Contributions: P.G., F.G. and X.Y. designed the idea. F.G. and X.Y. fabricated the PSCs. F.G. and X.Y. conducted characterizations. Y.L. helped with the theoretical calculation. Y.C. performed the synthesis. C.L. and C.L helped with manuscript revision. C.L. helped with the AFM measurements. F.G. wrote the first manuscript. P.G. provided financial support, guided the project, and revised the manuscript. All authors have read and agreed to the published version of the manuscript.

For research articles with several authors, a short paragraph specifying their individual contributions must be provided. The following statements should be used "

Conceptualization, P.G., F.G. and X.Y.; methodology, F.G. and X.Y.; theoretical calculation, Y.L.; molecular synthesis, Y.C.; data curation, F.G., X.Y. and C.L; data interpretation, F.G. and C.L; writing—original draft preparation, F.G.; writing—review and editing, G.P.; funding acquisition, P.G.; All authors have read and agreed to the published version of the manuscript.

Funding: P.G. acknowledges the financial support from the National Natural Science Foundation of China (Grant nos. 22175180, 21975260, 52311530673).

Institutional Review Board Statement: Not applicable.

Informed Consent Statement: Not applicable.

Data Availability Statement: All data are available upon request.

Acknowledgments: HZWTECH are thanked for allowing use of the DS-PAW and BDF code in Device Studio. The authors also gratefully acknowledge HZWTECH for supporting the computational resources.

Conflicts of Interest: The authors declare no conflict of interest.

References

- 1. McMeekin, D.P.; Sadoughi, G.; Rehman, W.; Eperon, G.E.; Saliba, M.; Hörantner, M.T.; Haghighirad, A.; Sakai, N.; Korte, L.; Rech, B.; et al. A Mixed-Cation Lead Mixed-Halide Perovskite Absorber for Tandem Solar Cells. *Science* **2016**, *351*, 151–155, doi:10.1126/science.aad5845.
- Steirer, K.X.; Schulz, P.; Teeter, G.; Stevanovic, V.; Yang, M.; Zhu, K.; Berry, J.J. Defect Tolerance in Methylammonium Lead Triiodide Perovskite. ACS Energy Lett. 2016, 1, 360–366, doi:10.1021/acsenergylett.6b00196.
- 3. Dong, Q.; Fang, Y.; Shao, Y.; Mulligan, P.; Qiu, J.; Cao, L.; Huang, J. Electron-Hole Diffusion Lengths > 175 Mm in Solution-Grown CH₃NH₃PbI₃ Single Crystals. *Science* **2015**, 347, 967–970, doi:10.1126/science.aaa5760.

- 4. D'Innocenzo, V.; Grancini, G.; Alcocer, M.J.P.; Kandada, A.R.S.; Stranks, S.D.; Lee, M.M.; Lanzani, G.; Snaith, H.J.; Petrozza, A. Excitons versus Free Charges in Organo-Lead Tri-Halide Perovskites. *Nat Commun* **2014**, *5*, 3586, doi:10.1038/ncomms4586.
- 5. Yin, W.-J.; Shi, T.; Yan, Y. Unusual Defect Physics in CH₃NH₃PbI₃ Perovskite Solar Cell Absorber. *Appl. Phys. Lett.* **2014**, *104*, 063903, doi:10.1063/1.4864778.
- 6. Saliba, M.; Stolterfoht, M.; Wolff, C.M.; Neher, D.; Abate, A. Measuring Aging Stability of Perovskite Solar Cells. *Joule* **2018**, 2, 1019–1024, doi:10.1016/j.joule.2018.05.005.
- Heo, J.H.; Han, H.J.; Kim, D.; Ahn, T.K.; Im, S.H. Hysteresis-Less Inverted CH₃NH₃PbI₃ Planar Perovskite Hybrid Solar Cells with 18.1% Power Conversion Efficiency. *Energy Environ. Sci.* 2015, 8, 1602–1608, doi:10.1039/C5EE00120J.
- 8. Al-Ashouri, A.; Köhnen, E.; Li, B.; Magomedov, A.; Hempel, H.; Caprioglio, P.; Márquez, J.A.; Morales Vilches, A.B.; Kasparavicius, E.; Smith, J.A.; et al. Monolithic Perovskite/Silicon Tandem Solar Cell with >29% Efficiency by Enhanced Hole Extraction. *Science* 2020, 370, 1300–1309, doi:10.1126/science.abd4016.
- 9. Guo, T.; Zhang, Z.; Yu, L.; Yuan, H.; Zhang, J.; Liu, X.; Hu, Z.; Zhu, Y. Synthesis of Well Dispersed NiO Ink for Efficient Perovskite Solar Cells. *J. Alloys Compd.* **2021**, *860*, 157889, doi:10.1016/j.jallcom.2020.157889.
- 10. Liu, L.; Ma, Y.; Wang, Y.; Ma, Q.; Wang, Z.; Yang, Z.; Wan, M.; Mahmoudi, T.; Hahn, Y.-B.; Mai, Y. Hole-Transport Management Enables 23%-Efficient and Stable Inverted Perovskite Solar Cells with 84% Fill Factor. *Nano-Micro Lett.* **2023**, *15*, 117, doi:10.1007/s40820-023-01088-4.
- 11. Zhang, S.; Ye, F.; Wang, X.; Chen, R.; Zhang, H.; Zhan, L.; Jiang, X.; Li, Y.; Ji, X.; Liu, S.; et al. Minimizing Buried Interfacial Defects for Efficient Inverted Perovskite Solar Cells. *Science* **2023**, *380*, 404–409, doi:10.1126/science.adg3755.
- 12. Zhao, Z.; Liu, W.; Kong, T.; Liu, Y.; Chen, W.; Gao, P.; Bi, D. Phosphates Modulated NiO_x HTL toward a Lower V_{oc} Loss in Wide Bandgap Perovskite Solar Cells. *Adv. Funct. Mater.* **2024**, 2419393, doi:10.1002/adfm.202419393.
- 13. Boyd, C.C.; Shallcross, R.C.; Moot, T.; Kerner, R.; Bertoluzzi, L.; Onno, A.; Kavadiya, S.; Chosy, C.; Wolf, E.J.; Werner, J.; et al. Overcoming Redox Reactions at Perovskite-Nickel Oxide Interfaces to Boost Voltages in Perovskite Solar Cells. *Joule* **2020**, *4*, 1759–1775, doi:10.1016/j.joule.2020.06.004.
- 14. Li, M.; Zhang, Z.; Sun, J.; Liu, F.; Chen, J.; Ding, L.; Chen, C. Perovskite Solar Cells with NiO_x Hole-Transport Layer. *J. Semicond.* **2023**, 44, 100201–100204, doi:2023101814535500.
- 15. Zhou, Y.; Huang, X.; Zhang, J.; Zhang, L.; Wu, H.; Zhou, Y.; Wang, Y.; Wang, Y.; Fu, W.; Chen, H. Interfacial Modification of NiO_x for Highly Efficient and Stable Inverted Perovskite Solar Cells. *Adv. Energy Mater.* **2024**, *14*, 2400616, doi:10.1002/aenm.202400616.
- 16. Liu, L.; Yang, Y.; Du, M.; Cao, Y.; Ren, X.; Zhang, L.; Wang, H.; Zhao, S.; Wang, K.; Liu, S. (Frank) Self-Assembled Amphiphilic Monolayer for Efficient and Stable Wide-Bandgap Perovskite Solar Cells. *Adv. Energy Mater.* **2023**, *13*, 2202802, doi:10.1002/aenm.202202802.
- 17. Liu, S.; Li, J.; Xiao, W.; Chen, R.; Sun, Z.; Zhang, Y.; Lei, X.; Hu, S.; Kober-Czerny, M.; Wang, J.; et al. Buried Interface Molecular Hybrid for Inverted Perovskite Solar Cells. *Nature* **2024**, *632*, 536–542, doi:10.1038/s41586-024-07723-3.
- Wang, Q.; Chueh, C.; Zhao, T.; Cheng, J.; Eslamian, M.; Choy, W.C.H.; Jen, A.K. -Y. Effects of Self-Assembled Monolayer Modification of Nickel Oxide Nanoparticles Layer on the Performance and Application of Inverted Perovskite Solar Cells. ChemSusChem 2017, 10, 3794–3803, doi:10.1002/cssc.201701262.
- 19. Yu, S.; Xiong, Z.; Zhou, H.; Zhang, Q.; Wang, Z.; Ma, F.; Qu, Z.; Zhao, Y.; Chu, X.; Zhang, X.; et al. Homogenized NiO_x Nanoparticles for Improved Hole Transport in Inverted Perovskite Solar Cells. *Science* **2023**, *382*, 1399−1404, doi:10.1126/science.adj8858.
- 20. Yu, X.; Liu, C.; Li, C.; Wang, C.; Li, Y.; Liang, L.; Yu, W.; Wang, Y.; Liu, C.; Liu, Y.; et al. Controlled NiO_x Defect Engineering to Harnessing Redox Reactions in Perovskite Photovoltaic Cells via Atomic Layer Deposition. *ACS Appl. Mater. Interfaces* **2024**, *16*, 31114–31125, doi:10.1021/acsami.4c03761.
- 21. Li, C.; Zhang, Z.; Zhang, H.; Yan, W.; Li, Y.; Liang, L.; Yu, W.; Yu, X.; Wang, Y.; Yang, Y.; et al. Fully Aromatic Self-Assembled Hole-Selective Layer toward Efficient Inverted Wide-Bandgap Perovskite Solar Cells with Ultraviolet Resistance. *Angew. Chem., Int. Ed.* 2024, 63, e202315281, doi:10.1002/anie.202315281.

- 22. Sun, J.; Shou, C.; Sun, J.; Wang, X.; Yang, Z.; Chen, Y.; Wu, J.; Yang, W.; Long, H.; Ying, Z.; et al. NiO_x-Seeded Self-Assembled Monolayers as Highly Hole-Selective Passivating Contacts for Efficient Inverted Perovskite Solar Cells. *Solar RRL* **2021**, *5*, 2100663, doi:10.1002/solr.202100663.
- 23. Guo, Y.; Huang, L.; Wang, C.; Huang, J.; Liu, S.; Liu, X.; Zhang, J.; Hu, Z.; Zhu, Y. Efficient Inverted Perovskite Solar Cells with a Low-Temperature Processed NiO_x/SAM Hole Transport Layer. *J. Mater. Chem. C* 2024, 12, 1507–1515, doi:10.1039/D3TC03575A.
- 24. Mao, L.; Yang, T.; Zhang, H.; Shi, J.; Hu, Y.; Zeng, P.; Li, F.; Gong, J.; Fang, X.; Sun, Y.; et al. Fully Textured, Production-Line Compatible Monolithic Perovskite/Silicon Tandem Solar Cells Approaching 29% Efficiency. *Adv. Mater.* 2022, 34, 2206193, doi:10.1002/adma.202206193.
- 25. Yamaguchi, S.; Sato, A.; Ajiro, K.; Shiokawa, M.; Hashimoto, Y.; Maeda, T.; Sugiyama, M.; Gotanda, T.; Marumoto, K. Performance Improvement Mechanisms of Perovskite Solar Cells by Modification of NiO_x Hole-Selectivecontacts with Self-Assembled-Monolayers. *Sol. Energy Mater. Sol. Cells* **2023**, *258*, 112428, doi:10.1016/j.solmat.2023.112428.
- 26. Wu, M.; Li, X.; Ying, Z.; Chen, Y.; Wang, X.; Zhang, M.; Su, S.; Guo, X.; Sun, J.; Shou, C.; et al. Reconstruction of the Indium Tin Oxide Surface Enhances the Adsorption of High-Density Self-Assembled Monolayer for Perovskite/Silicon Tandem Solar Cells. *Adv. Funct. Mater.* **2023**, *33*, 2304708, doi:10.1002/adfm.202304708.
- 27. Armstrong, N.R.; Carter, C.; Donley, C.; Simmonds, A.; Lee, P.; Brumbach, M.; Kippelen, B.; Domercq, B.; Yoo, S. Interface Modification of ITO Thin Films: Organic Photovoltaic Cells. *Thin Solid Films* **2003**, 445, 342–352, doi:10.1016/j.tsf.2003.08.067.
- 28. Guo, R.; Wang, X.; Jia, X.; Guo, X.; Li, J.; Li, Z.; Sun, K.; Jiang, X.; Alvianto, E.; Shi, Z.; et al. Refining the Substrate Surface Morphology for Achieving Efficient Inverted Perovskite Solar Cells. *Adv. Energy Mater.* **2023**, *13*, 2302280, doi:10.1002/aenm.202302280.
- 29. Xu, Y.; Liu, G.; Hu, J.; Wang, G.; Chen, M.; Chen, Y.; Li, M.; Zhang, H.; Chen, Y. In Situ Polymer Network in Perovskite Solar Cells Enabled Superior Moisture and Thermal Resistance. *J. Phys. Chem. Lett.* **2022**, *13*, 3754–3762, doi:10.1021/acs.jpclett.2c00811.
- 30. Phung, N.; Verheijen, M.; Todinova, A.; Datta, K.; Verhage, M.; Al-Ashouri, A.; Köbler, H.; Li, X.; Abate, A.; Albrecht, S.; et al. Enhanced Self-Assembled Monolayer Surface Coverage by ALD NiO in P-i-n Perovskite Solar Cells. *ACS Appl. Mater. Interfaces* **2021**, *14*, 2166–2176, doi:10.1021/acsami.1c15860.
- 31. Tang, H.; Shen, Z.; Shen, Y.; Yan, G.; Wang, Y.; Han, Q.; Han, L. Reinforcing Self-Assembly of Hole Transport Molecules for Stable Inverted Perovskite Solar Cells. *Science* **2024**, *383*, 1236–1240, doi:10.1126/science.adj9602.
- 32. Yang, D.; Zhou, X.; Yang, R.; Yang, Z.; Yu, W.; Wang, X.; Li, C.; Liu, S. (Frank); Chang, R.P.H. Surface Optimization to Eliminate Hysteresis for Record Efficiency Planar Perovskite Solar Cells. *Energy Environ. Sci.* 2016, *9*, 3071–3078, doi:10.1039/C6EE02139E.
- 33. Almora, O.; Aranda, C.; Mas-Marzá, E.; Garcia-Belmonte, G. On Mott-Schottky Analysis Interpretation of Capacitance Measurements in Organometal Perovskite Solar Cells. *Appl. Phys. Lett.* **2016**, *109*, 173903, doi:10.1063/1.4966127.
- 34. Bi, C.; Wang, Q.; Shao, Y.; Yuan, Y.; Xiao, Z.; Huang, J. Non-Wetting Surface-Driven High-Aspect-Ratio Crystalline Grain Growth for Efficient Hybrid Perovskite Solar Cells. *Nat Commun* **2015**, *6*, 7747, doi:10.1038/ncomms8747.
- 35. Tan, Y.; Chang, X.; Zhong, J.-X.; Feng, W.; Yang, M.; Tian, T.; Gong, L.; Wu, W.-Q. Chemical Linkage and Passivation at Buried Interface for Thermally Stable Inverted Perovskite Solar Cells with Efficiency over 22%. *CCS Chem* **2023**, *5*, 1802–1814, doi:10.31635/ccschem.022.202202154.
- 36. Liu, W.; Hong, G.; Dai, D.; Li, L.; Dolg, M. The Beijing Four-Component Density Functional Program Package (BDF) and Its Application to EuO, EuS, YbO and YbS. *Theor Chem Acta* **1997**, *96*, 75–83, doi:10.1007/s002140050207.
- 37. Zhang, Y.; Suo, B.; Wang, Z.; Zhang, N.; Li, Z.; Lei, Y.; Zou, W.; Gao, J.; Peng, D.; Pu, Z.; et al. BDF: A Relativistic Electronic Structure Program Package. *J Chem Phys* **2020**, *152*, 064113, doi:10.1063/1.5143173.
- 38. Liu, W.; Wang, F.; Li, L. The Beijing Density Functional (BDF) Program Package: Methodologies and Applications. *J. Theor. Comput. Chem.* **2003**, *02*, 257–272, doi:10.1142/S0219633603000471.

- 39. Liu, W.; Wang, F.; Li, L. Relativistic Density Functional Theory: The Bdf Program Package. In *Recent Advances in Relativistic Molecular Theory*; Recent Advances in Computational Chemistry; WORLD SCIENTIFIC, 2004; Vol. Volume 5, pp. 257–282 ISBN 978-981-238-709-7.
- 40. Blöchl, P.E. Projector Augmented-Wave Method. *Phys. Rev. B* **1994**, *50*, 17953–17979, doi:10.1103/PhysRevB.50.17953.

Disclaimer/Publisher's Note: The statements, opinions and data contained in all publications are solely those of the individual author(s) and contributor(s) and not of MDPI and/or the editor(s). MDPI and/or the editor(s) disclaim responsibility for any injury to people or property resulting from any ideas, methods, instructions or products referred to in the content.